

Notice of References Cited	Application/Control No. 09/996,876	Applicant(s)/Patent Under Reexamination BAUMANN ET AL.	
	Examiner Michelle A Lazor	Art Unit 1734	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	EP 1035643	03-2000	EPO	Ooyama et al.	H02N 15/00
	O	WO 99/17034	04-1999	PCT	Nijssse et al.	F16F 6/00
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Derwent, English Abstract of JP 02185975 (Vapour coating wafer at sub-stmospheric pressure - with non-contact support e.g. with magnetic force or gas lift), 11 January 1989
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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